

In re Application of:

Tadahiro OHMI, et al.

Application No.: 09/531,958

Filed: March 21, 2000

For: LASER OSCILLATING APPARATUS,
EXPOSURE APPARATUS, AND DEVICE
FABRICATION METHOD

Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Supplemental Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	21	MINUS	21	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	6	MINUS	6	= 0	x \$42 \$84	\$ 0.00
Fee for Multiple Dependent claims \$140°/\$280						\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 0.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$_____ is enclosed.

Docket No. 00862.021870

Examiner: A. Rodriguez

Group Art Unit: 2828


July 18, 2002

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- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$____ to cover the fee for a ____ month extension is enclosed.
- ☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Michael E. Kondoudis
Registration No. 42,758

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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SUPPLEMENTAL AMENDMENT

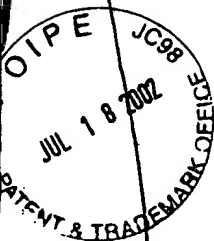
Sir:

Further to the Amendment and Petition for Extension of Time filed July 15, 2002, please amend the above-identified application as follows:

IN THE SPECIFICATION:

✓ Please substitute the paragraph starting at page 1, line 17 and ending at line 24, with the following paragraph. A marked-up copy of the paragraph, showing the changes made thereto, is attached.

--Recently, a so-called excimer laser has attracted attention as the only high-output laser that oscillates in the ultraviolet region, and a wide range of applications of the excimer laser can be expected in the electronic industry, chemical industry, energy industry



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